

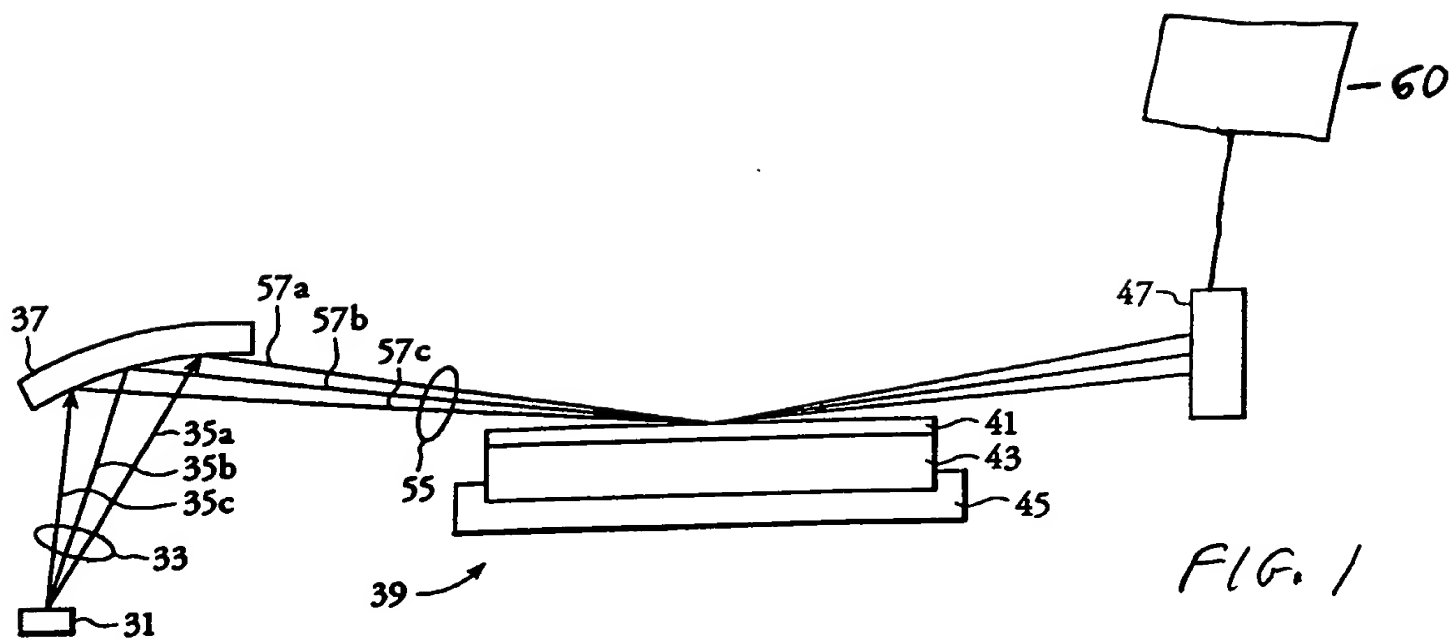
[illegible]

FIG. 1

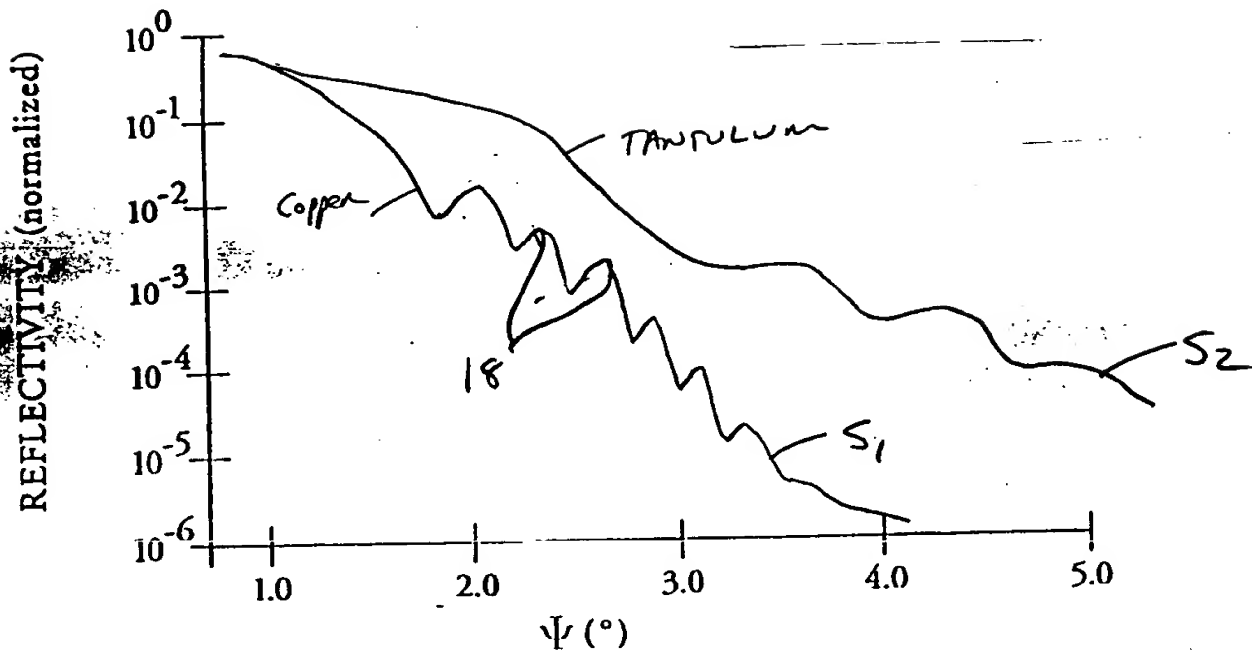


Fig 2

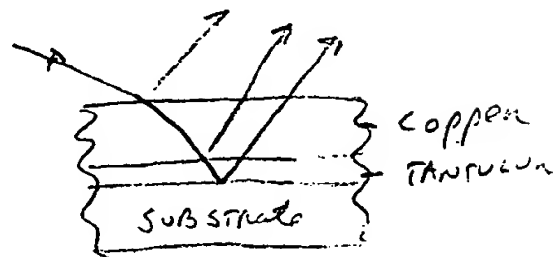
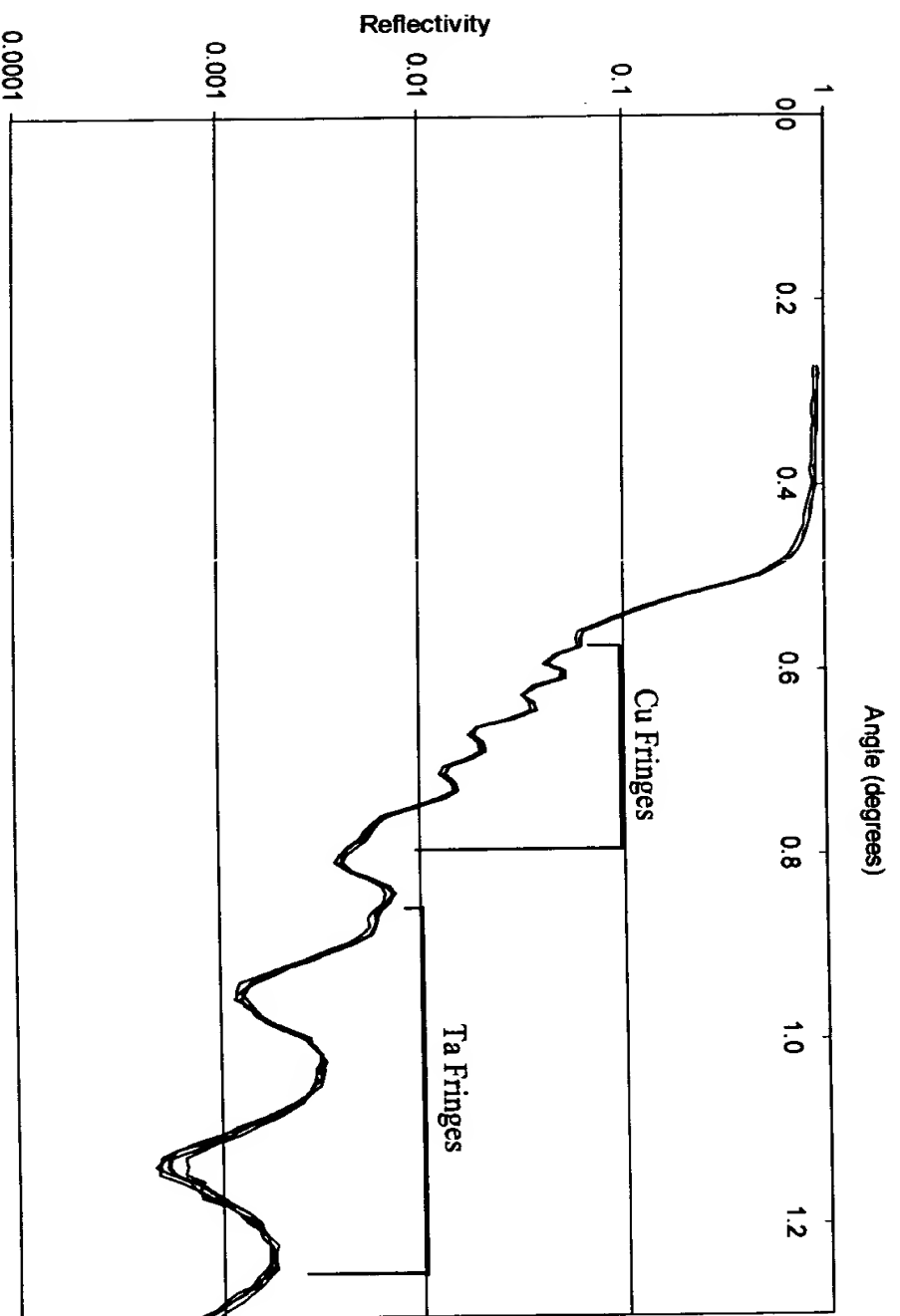


Fig 4

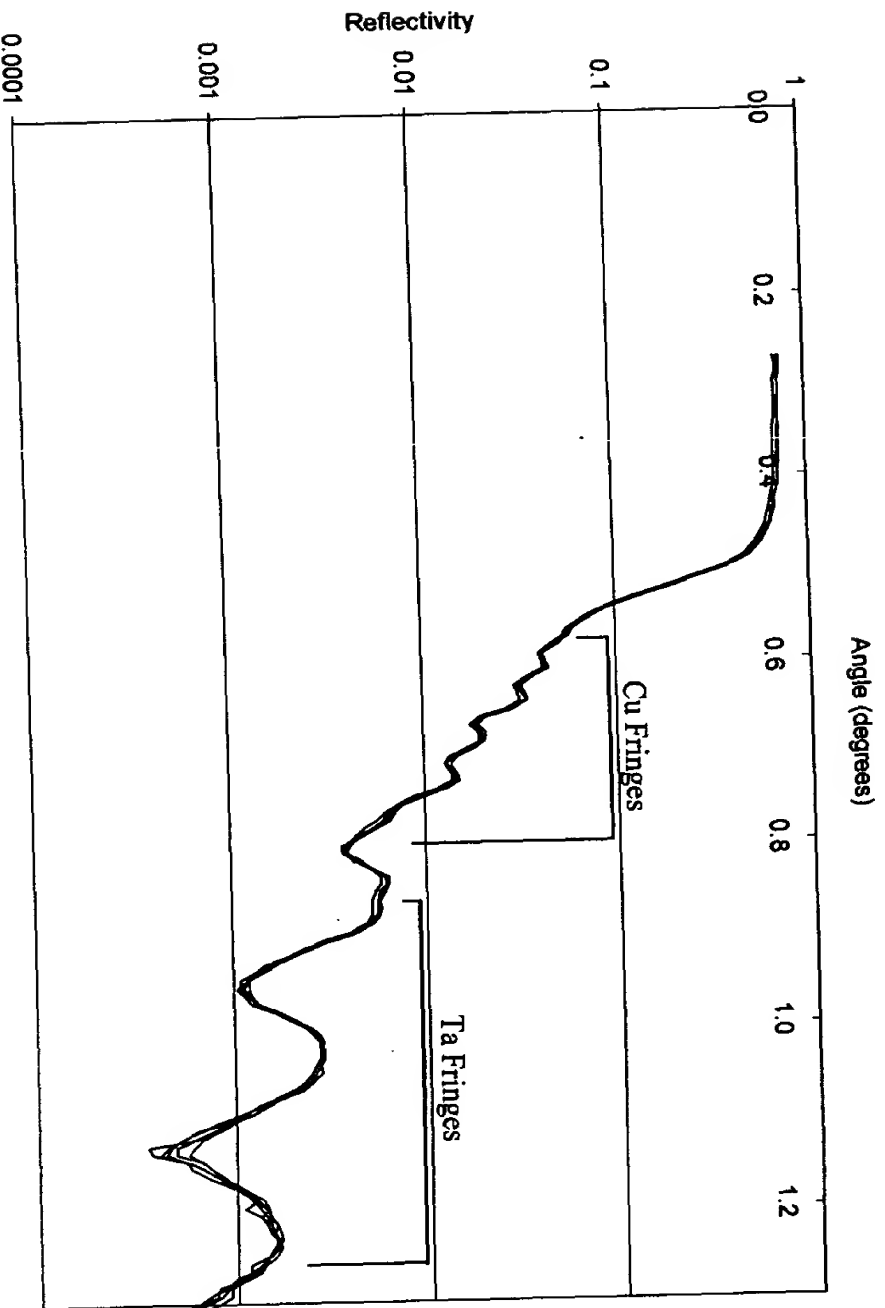
5 Measurements Over Same Area on Blanket Wafer (Cu Seed/Ta Barrier)



53

05/05/03 09:01:00

5 Measurements Over Same Area on Patterned Wafer (Cu Seed/Ta Barrier)



F 16.6

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